



Docket No.: R2184.0282/P282
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hirokazu Iwata et al.

Application No.: 10/765,502

Confirmation No.: 2556

Filed: January 28, 2004

Art Unit: N/A

For: METHOD OF GROWING GROUP III
NITRIDE CRYSTAL, GROUP III NITRIDE
CRYSTAL GROWN THEREBY, GROUP III
NITRIDE CRYSTAL GROWING
APPARATUS AND SEMICONDUCTOR
DEVICE

Examiner: Not Yet Assigned

CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENTS

MS Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following
prior foreign applications filed in the following foreign countries on the dates indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Japan	2003-019716	January 29, 2003
Japan	2003-071302	March 17, 2003
Japan	2003-081836	March 25, 2003
Japan	2004-011536	January 20, 2004
Japan	2004-012906	January 21, 2004
Japan	2004-013562	January 21, 2004

Application No.: 10/765,502

Docket No.: R2184.0282/P282

In support of this claim, a certified copy of each said original foreign application is filed herewith.

Dated: July 20, 2004

Respectfully submitted,

By 

Mark J. Thronson

Registration No.: 33,082

DICKSTEIN SHAPIRO MORIN &
OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 785-9700

Attorney for Applicant



Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: January 29, 2003

Application Number: Japanese Patent Application
No.2003-019716

[ST.10/C]: [JP2003-019716]

Applicant(s): RICOH COMPANY, LTD..

December 1, 2003

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2003-3098874

Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: March 17, 2003

Application Number: Japanese Patent Application
No.2003-071302

[ST.10/C]: [JP2003-071302]

Applicant(s): RICOH COMPANY, LTD.

December 1, 2003

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2003-3098880

Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: March 25, 2003

Application Number: Japanese Patent Application
No.2003-081836

[ST.10/C]: [JP2003-081836]

Applicant(s): RICOH COMPANY, LTD.

December 1, 2003

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2003-3098882



Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: January 20, 2004

Application Number: Japanese Patent Application
No.2004-011536

[ST.10/C]: [JP2004-011536]

Applicant(s): RICOH COMPANY, LTD.

March 3, 2004

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2004-3016100

Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: January 21, 2004

Application Number: Japanese Patent Application
No.2004-012906

[ST.10/C]: [JP2004-012906]

Applicant(s): RICOH COMPANY, LTD.

March 3, 2004

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2004-3016101

Japan Patent Office

This is to certify that the annexed is a true copy of the following application as filed with this Office.

Date of Application: January 21, 2004

Application Number: Japanese Patent Application
No.2004-013562

[ST.10/C]: [JP2004-013562]

Applicant(s): RICOH COMPANY, LTD.

March 3, 2004

Commissioner,
Japan Patent Office

Yasuo Imai (Seal)

Certificate No.2004-3016103